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HAXPES on SiO₂ with Ga K α photons

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Note: This paper is part of the 2022 Special Topic Collection on Higher Energy X-ray Photoelectron Spectroscopy.

ABSTRACT

Silicon oxide (SiO₂) grown by rapid thermal oxidation (RTO) was analyzed using high-resolution high-energy x-ray photoelectron spectroscopy (HAXPES). The HAXPES spectra of SiO₂ obtained using monochromatic Ga K α radiation at 9252.13 eV include a survey scan and high-resolution spectra of Si 1s, Si 2p, O 1s, and C 1s.

Key words: SiO₂, HAXPES, Ga K α

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Accession#: 01733 and 01734

Technique: XPS

Host Material: SiO₂

Instrument: Scienta Omicron, HAXPES Lab

Major Elements in Spectra: Si and O

Minor Elements in Spectra: C

Published Spectra: 6

Spectra in Electronic Record: 6

Spectral Category: Comparison

INTRODUCTION

While high-energy photoemission has been in use for decades, very few reference spectra are available, even for common materials. The recent availability of performant lab-scale photoemission spectrometers (Refs. 1–3) requires reliable reference data.

In this work, silicon oxide (SiO₂) grown by Rapid Thermal Oxidation (RTO) was analyzed using high-resolution high-energy x-ray photoelectron spectroscopy (HAXPES). The HAXPES spectra of SiO₂ obtained using monochromatic Ga K α radiation at 9252.13 eV include high-resolution spectra of Si 1s, Si 2p, O 1s, and C 1s. This work is submitted in parallel to HAXPES spectra of identical SiO₂ samples obtained at imec using monochromatic Cr K α radiation at 5414.8 eV.

SPECIMEN DESCRIPTION (ACCESSION # 01734)

Host Material: SiO₂

CAS Registry #: 7631-86-9

Host Material Characteristics: Homogeneous; solid; amorphous; dielectric; inorganic compound; thin film

Chemical Name: Silicon dioxide

Source: RTO-grown SiO₂

Host Composition: Si

Form: Film

Structure: Amorphous film

History and Significance: Air exposed RTO SiO₂

As Received Condition: As grown-air exposed, piece of a 200 mm wafer

Analyzed Region: Same as the host material

Ex Situ Preparation/Mounting: Mounted on a double-sided conducting tape.

In Situ Preparation: None

Charge Control: No electron nor ion flood guns are used

Temp. During Analysis: 300 K

Pressure During Analysis: $<2 \times 10^{-7}$ Pa

Pre-analysis Beam Exposure: 0 s

SPECIMEN DESCRIPTION (ACCESSION # 01733)

Host Material: Au

CAS Registry #: 7440-57-5

Host Material Characteristics: Homogeneous; solid; amorphous; conductor; metal; other

Chemical Name: Gold
Source: Sputtered thin film Au (500 nm)/Cr (50 nm) on silicon
Host Composition: Au
Form: Film
Structure: Amorphous
History and Significance: Long-time in-UHV reference sample (sputtered)
As Received Condition: Piece of a Si wafer
Analyzed Region: Same as host materials
Ex Situ Preparation/Mounting: The sample was taped on the sample holder using an insulating removable 3 M double-sided tape.
In Situ Preparation: None
Charge Control: None
Temp. During Analysis: 300 K
Pressure During Analysis: $<2 \times 10^{-7}$ Pa
Pre-analysis Beam Exposure: 0s

INSTRUMENT DESCRIPTION

Manufacturer and Model: Scienta Omicron, HAXPES Lab
Analyzer Type: Spherical sector
Detector: Two multichannel plates with a phosphor screen and a digital camera detection system
Number of Detector Elements: A camera detector with 512 pixels in the dispersive direction

INSTRUMENT PARAMETERS COMMON TO ALL SPECTRA

Spectrometer

Analyzer Mode: Constant pass energy
Throughput ($T = E^N$): $N = -2$
Excitation Source Window: The exit window of the Ga-source is Be. The HAX9-5 entrance and exit windows are Capton (Polyamid) windows.
Excitation Source: Ga K_{α} monochromatic
Source Energy: 9252.13 eV
Source Strength: 250 W
Source Beam Size: $80 \times 20 \mu\text{m}^2$
Signal Mode: Multichannel direct

Geometry

Incident Angle: 3°
Source-to-Analyzer Angle: 90°
Emission Angle: 87°
Specimen Azimuthal Angle: 0°
Specimen Polar Angle: -3°

Acceptance Angle from Analyzer Axis: $0^{\circ} \pm 30^{\circ}$ from the lens axis in one angular dispersive direction
Analyzer Angular Acceptance Width: $60^{\circ} \times 60^{\circ}$

DATA ANALYSIS METHOD

Energy Scale Correction: Due to the too low intensity of the C 1s peak with Ga K_{α} , the binding energy was referenced by determining the binding energy position of the Si 2p peak recorded by the Al K_{α} XPS measurement and the subsequent correction shift of the C 1s peak to 284.8 eV. The determined binding energy position of the Si 2p peak is 103.4 eV. The binding energy shift of the Ga K_{α} data was then performed by shifting the Si 2p peak to 103.4 eV.

Recommended Energy Scale Shift: -1.9 eV for binding energy (i.e., the Si 2p peak is shifted from 105.3 to 103.4 eV)

Peak Shape and Background Method: Data treatment was performed using a Shirley background with parameters Av Width 5, St Offset 0, and End Offset 0.

Quantitation Method: Data treatment was performed using CasaXPS software version 2.3.17PR1.1. Theoretical sensitivity factors have been used, more in detail 3.45, 30, and 0.343 for O 1s, Si 1s, and Si 2p, respectively.

ACKNOWLEDGMENTS

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AUTHOR DECLARATIONS

Conflict of Interest

The authors have no conflicts to disclose.

DATA AVAILABILITY

The data that support the findings of this study are available within the article and its [supplementary material](#) (Ref. 4).

REFERENCES

- ¹See <https://www.ulvac-phi.com/en/products/xps/quantex/>
- ²See <https://www.kratos.com/products/axis-supra-xps-surface-analysis-instrument>
- ³See <https://scientaomicron.com/en/system-solutions/electron-spectroscopy/HAXPES-Lab>
- ⁴See [supplementary material](#) at <https://www.scitation.org/doi/suppl/10.1116/6.0001523> for the figures.

SPECTRAL FEATURES TABLE

Spectrum ID #	Element/Transition	Peak Energy (eV)	Peak Width FWHM (eV)	Peak Area (eV × cts/s)	Sensitivity Factor	Concentration (at. %)	Peak Assignment
01734-02	Si 1s	1843.9	1.76	4586	30	38.05	SiO ₂
01734-03	Si 2p	103.4	1.63	45	0.343	...	SiO ₂
01734-04	O 1s	532.9	1.57	827.1	3.45	60.74	SiO ₂
01734-05	C 1s	284.8	1.49	4.71	1	1.22	Contamination

ANALYZER CALIBRATION TABLE

Spectrum ID #	Element/Transition	Peak Energy (eV)	Peak Width FWHM (eV)	Peak Area (eV × cts/s)	Sensitivity Factor	Concentration (at. %)	Peak Assignment
...	Au 4f _{7/2}	83.34 ^a	0.94	184.5

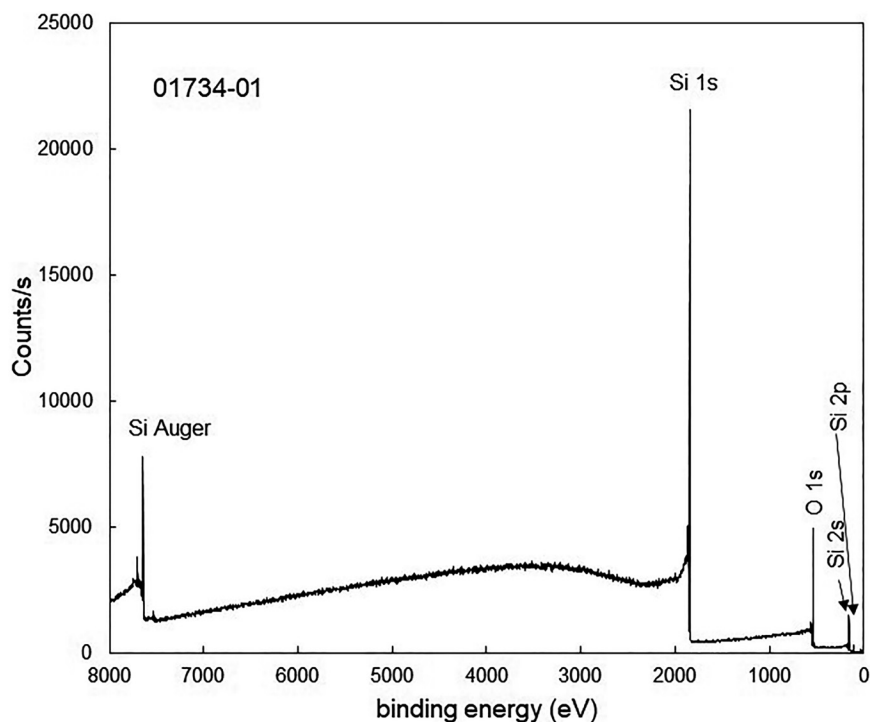
^aNo binding energy correction shift applied.

GUIDE TO FIGURES

Spectrum (Accession) #	Spectral Region	Voltage Shift ^a	Multiplier	Baseline	Comment #
01734-01	Survey	0	1	0	...
01734-02	Si 1s	1.9	1	0	...
01734-03	Si 2p	1.9	1	0	...
01734-04	O 1s	1.9	1	0	...
01734-05	C 1s	1.9	1	0	...
01733-01	Survey	0	1	0	Au reference ^b

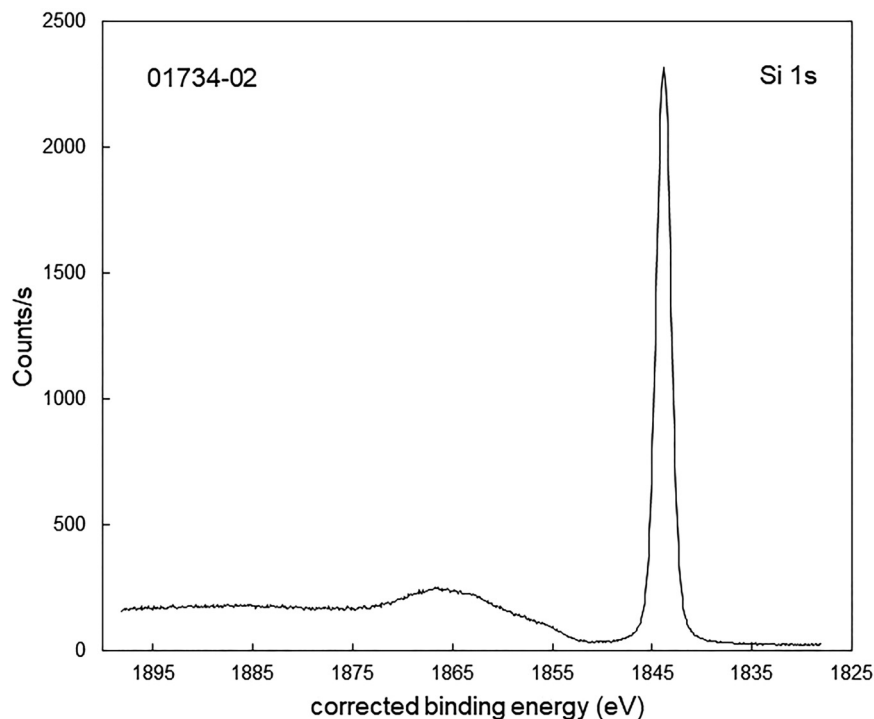
^aVoltage shift of the archived (as-measured) spectrum relative to the printed figure. The figure reflects the recommended energy scale correction due to a calibration correction, sample charging, flood gun, or other phenomenon.

^bThe reference spectrum included in this article is the same as those included with other articles in this collection that use this x-ray source. This was intentional and not an error as submissions were requested to be accompanied by a wide-scan spectrum of sputter-cleaned gold taken on the same instrument and using the same settings as the wide-scan spectrum of the material or materials in the submission.



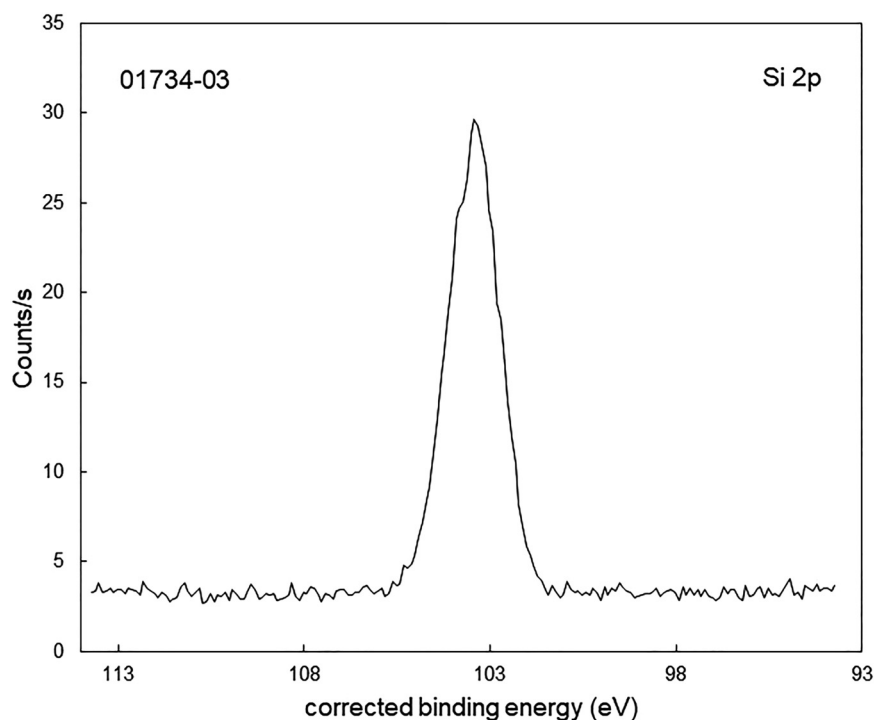
Accession #	01734-01
Host Material:	SiO ₂
Technique:	XPS
Spectral Region:	Survey
Instrument:	Scienta Omicron, HAXPES Lab
Excitation Source:	Ga K _α monochromatic
Source Energy:	9252.13 eV
Source Strength:	250 W
Source Size:	0.08 × 0.02 mm ²
Analyzer Type:	Spherical sector analyzer
Incident Angle:	3°
Emission Angle:	87°
Analyzer Pass Energy:	500 eV
Analyzer Resolution:	1.25 eV
Total Signal Accumulation Time:	5274 s
Total Elapsed Time:	5275 s
Number of Scans:	10
Effective Detector Width:	40 eV

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- Accession #: 01734-02
- Host Material: SiO₂
- Technique: XPS
- Spectral Region: Si 1s

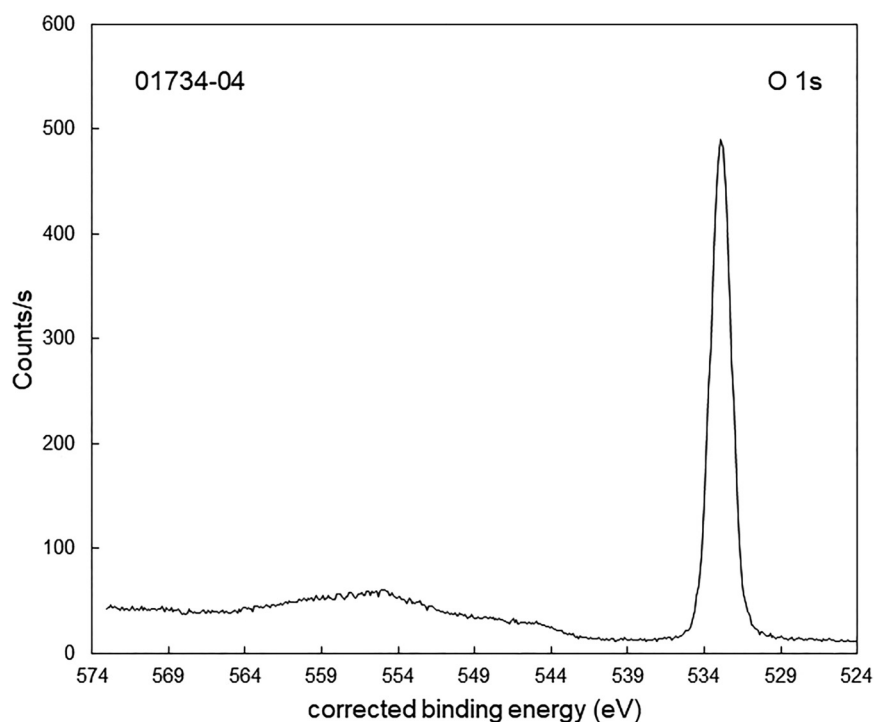
Instrument: Scienta Omicron, HAXPES Lab
 Excitation Source: Ga K_α monochromatic
 Source Energy: 9252.13 eV
 Source Strength: 250 W
 Source Size: 0.08 × 0.02 mm²
 Analyzer Type: Spherical sector
 Incident Angle: 3°
 Emission Angle: 87°
 Analyzer Pass Energy 100 eV
 Analyzer Resolution: 0.25 eV
 Total Signal Accumulation Time: 10 786 s
 Total Elapsed Time: 10 800 s
 Number of Scans: 70
 Effective Detector Width: 8 eV



- Accession #: 01734-03
- Host Material: SiO₂
- Technique: XPS
- Spectral Region: Si 2p

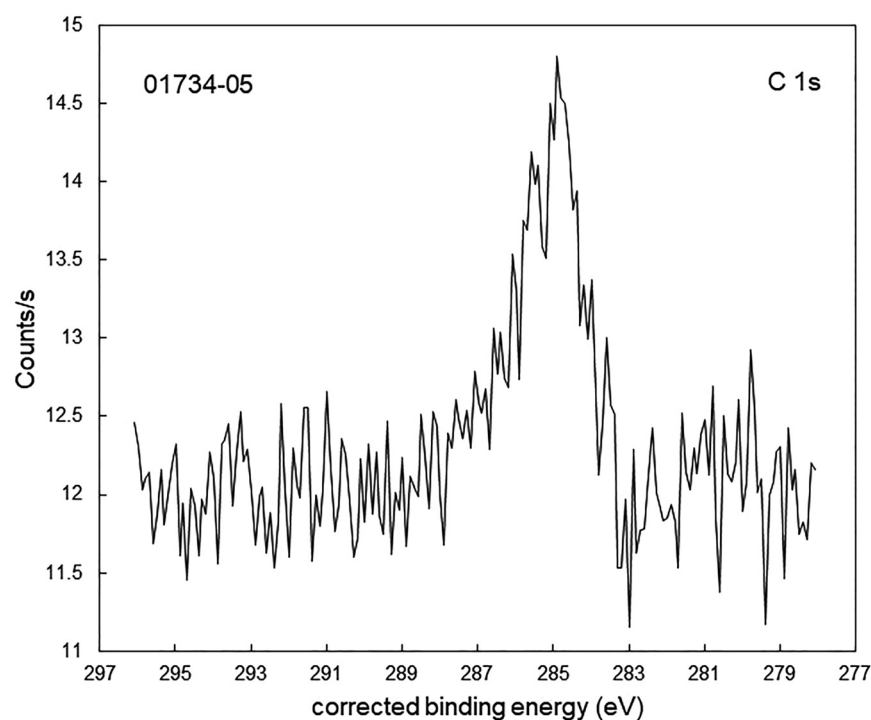
Instrument: Scienta Omicron, HAXPES Lab
 Excitation Source: Ga K_α monochromatic
 Source Energy: 9252.13 eV
 Source Strength: 250 W
 Source Size: 0.08 × 0.02 mm²
 Analyzer Type: Spherical sector
 Incident Angle: 3°
 Emission Angle: 87°
 Analyzer Pass Energy 100 eV
 Analyzer Resolution: 0.25 eV
 Total Signal Accumulation Time: 16 143 s
 Total Elapsed Time: 16 200 s
 Number of Scans: 285
 Effective Detector Width: 8 eV

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■ Accession #: [01734-04](#)
 ■ Host Material: SiO₂
 ■ Technique: XPS
 ■ Spectral Region: O 1s

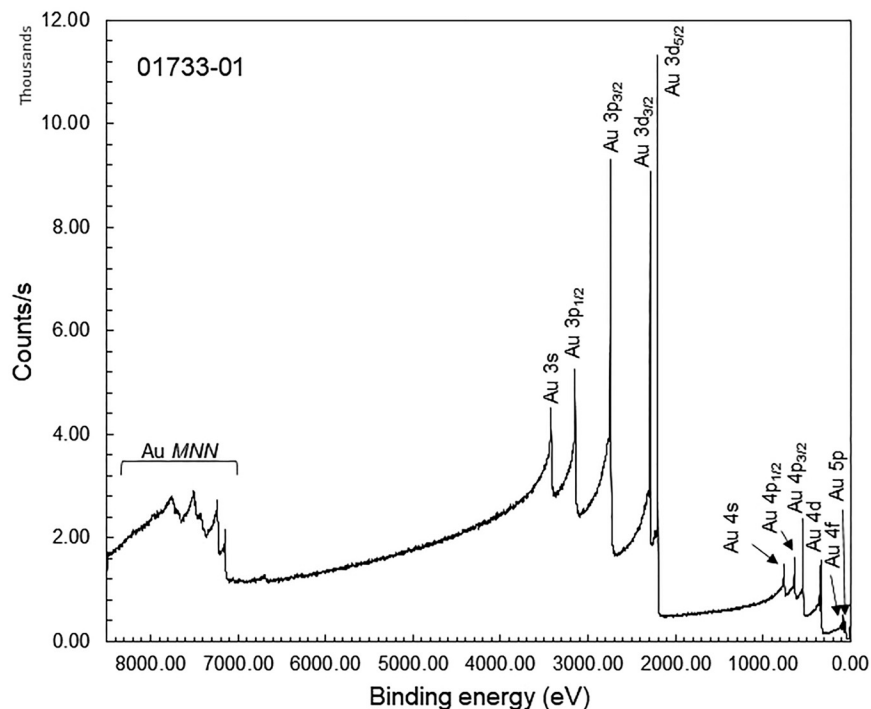
Instrument: Scienta Omicron, HAXPES Lab
 Excitation Source: Ga K_α monochromatic
 Source Energy: 9252.13 eV
 Source Strength: 250 W
 Source Size: 0.08 × 0.02 mm²
 Analyzer Type: Spherical sector
 Incident Angle: 3°
 Emission Angle: 87°
 Analyzer Pass Energy 100 eV
 Analyzer Resolution: 0.25 eV
 Total Signal Accumulation Time: 12 579 s
 Total Elapsed Time: 12 600 s
 Number of Scans: 106
 Effective Detector Width: 8 eV



■ Accession #: [01734-05](#)
 ■ Host Material: SiO₂
 ■ Technique: XPS
 ■ Spectral Region: C 1s

Instrument: Scienta Omicron, HAXPES Lab
 Excitation Source: Ga K_α monochromatic
 Source Energy: 9252.13 eV
 Source Strength: 250 W
 Source Size: 0.08 × 0.02 mm²
 Analyzer Type: Spherical sector
 Incident Angle: 3°
 Emission Angle: 87°
 Analyzer Pass Energy 100 eV
 Analyzer Resolution: 0.25 eV
 Total Signal Accumulation Time: 30 621 s
 Total Elapsed Time: 30 725 s
 Number of Scans: 522
 Effective Detector Width: 8 eV

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Accession #	01733-01
Host Material:	Au
Technique:	XPS
Spectral Region:	Survey
Instrument:	Scienta Omicron, HAXPES Lab
Excitation Source:	Ga K _α monochromatic
Source Energy:	9252.13 eV
Source Strength:	250 W
Source Size:	0.08 × 0.02 mm ²
Analyzer Type:	Spherical sector analyzer
Incident Angle:	3°
Emission Angle:	87°
Analyzer Pass Energy:	500 eV
Analyzer Resolution:	1.25 eV
Total Signal Accumulation Time:	5274 s
Total Elapsed Time:	5275 s
Number of Scans:	10
Effective Detector Width:	40 eV

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